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CLAIMS

1. An antimicrobial substrate having adhered to at least a part of its surface an organosilicon quaternary ammonium salt compound, c h a r a c t e r i z ed in further having adhered to at least a part of its surface a cationic polymer.

- 2. A substrate according to claim 1, wherein the cationic polymer is a hydrophilic polymer.
 - 3. A substrate according to claim 1 or claim 2, wherein the cationic polymer comprises -NH- in the polymeric backbone.

4. A substrate according to claim 3, wherein the cationic polymer is a polyethylene imine.

- 5. A substrate according to claim 3, wherein the cationic polymer is polyhexamethylene biguanide hydrochloride (PHMB).
- 6. A substrate according to any one of claims 1-5, wherein the antimicrobial organosilicon quaternary ammonium salt compound is according to Formula II

$$\begin{bmatrix} R_2 & R_1 \\ N & R_4 & Si(OR_5)_3 \end{bmatrix}^+ X^-$$

Formula II

wherein

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 R_1 is an C_{1-30} alkyl group, preferably an C_{8-30} alkyl 30 group,

 \mbox{R}_2 and $\mbox{R}_3,$ \mbox{R}_4 and \mbox{R}_5 each independently are an $\mbox{C}_{1\text{--}30}$ alkyl group or hydrogen, and

X is a counter ion, such as Cl, Br, I or CH3COO.

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7. A substrate according to claim 6, wherein the antimicrobial organosilicon quaternary ammonium salt compound is 3-(trimethoxysilyl)propyl-dimethyloctadecyl ammonium chloride.

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8. A method for producing an antimicrobial substrate according to any one of claims 1-7 characterised in comprising:

adhering an organosilicon quaternary ammonium salt compound to at least a part of the substrate surface, and adhering a cationic polymer to at least a part of the substrate surface.

9. A composition for use in the production of an antimicrobial substrate according to any one of claims 1-7,
c h a r a c t e r i s e d in comprising an organosilicon
quaternary ammonium salt compound and a cationic polymer.